

*Cofle*  
00862.022072

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

MASATO MURAKI ET AL.

Appln. No.: 09/733,980

Filed: December 12, 2000

For: CHARGED-PARTICLE BEAM

EXPOSURE APPARATUS, CHARGED-

PARTICLE BEAM EXPOSURE

METHOD, CONTROL DATA

DETERMINATION METHOD, AND

DEVICE MANUFACTURING METHOD

USING THIS METHOD

U.S. Patent No.: 6,903,352 B2

Issued: June 7, 2005

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Examiner: Nikita Wells

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Art Unit: 2881

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August 10, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER CALLING ATTENTION TO ERROR IN PATENT

Sir:

The following minor errors have been noted in the above-mentioned patent:

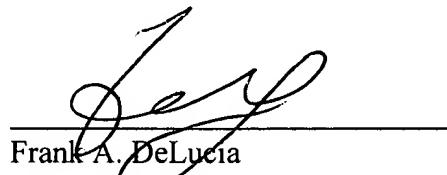
COLUMN 18

Line 47, "formed, wherein" should read --formed, ¶ wherein--.

This error appears to be relatively insignificant and, therefore, we do not believe it is necessary to request a Certificate of Correction. However, it is requested that this paper be placed in the filewrapper of the above-identified patent.

Patentees' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Frank A. DeLucia  
Attorney for Patentees  
Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200

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